



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki OGAWA

Group Art Unit: 2623

Application No.: 09/556,824

Examiner: C. KIM

Filed: April 21, 2000

Docket No.: 136159

For: METHOD FOR OBSERVING OBJECT BY PROJECTION, METHOD FOR
DETECTING MICROORGANISMS, AND PROJECTION DETECTING SYSTEM

NOTICE OF CHANGE OF ADDRESS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please address all future communications in connection with the above-
identified application to:

**OLIFF & BERRIDGE, PLC
CUSTOMER NUMBER 25944**

Respectfully submitted,

Ronald R. Snider
Registration No. 24,962

RRS/ldg

Date: February 19, 2008

**OLIFF & BERRIDGE, PLC
P.O. Box 320850
Alexandria, Virginia 22320-4850
Telephone: (703) 836-6400**

<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
